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Attorney Docket No. SEC.1151
Application No. 10/805,225

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of :
Sun-Lee Hwang et al. : Group Art Unit: 2812
Application No. 10/805,225 : Examiner: TBA
Filed: March 22, 2004 :

For: METHOD OF ALIGNING A SEMICONDUCTOR SUBSTRATE WITH A
SEMICONDUCTOR ALIGNMENT APPARATUS

**REQUEST TO CORRECT PTO'S POWER
OF ATTORNEY RECORDS**

U.S. Patent and Trademark Office
Customer Service Window
Randolph Building
401 Dulany Street
Alexandria VA 22314

Sir:

The U.S. Patent and Trademark Office records are apparently in error with respect to the power of attorney associated with the above-identified application.

Attached is a copy of the Declaration And Power Of Attorney which is of record in the above-identified application. As shown, power of attorney in the application is vested in the following individuals:

Adam C. Volentine, Reg. No. 33,289
William S. Francos, Reg. No. 38,456

Please correct the records within the U.S. Patent and Trademark Office to reflect the above-individuals as having power of attorney.

Also, submitted herewith is a Change of Correspondence Address form executed by undersigned, who has power of attorney as noted above.

Respectfully submitted,

Volentine Francos & Whitt, PLLC

A handwritten signature in black ink, appearing to read 'Adam C. Volentine', with a stylized flourish extending from the end.

Adam C. Volentine
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Date: July 13, 2005